



Atty. Docket No. OPP-GZ-2005-0062-US-D0

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

:

Geon-Ook Park

: GROUP ART UNIT: 2814

APPLICATION NO: 10/817,096

:

FILED: April 2, 2004

: EXAMINER: Pham, Long

FOR: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF

I hereby certify that this document is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 6, 2006.

By:


Jennie HeatonAMENDMENT UNDER 37 C.F.R. 1.312

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SIR:

Responsive to the Notice of Allowance dated June 8, 2006, Applicant respectfully requests entry of the following amendments in the above-identified application.